

# Nitrogen dioxide sensing properties of sprayed tungsten oxide thin film sensor: Effect of film thickness

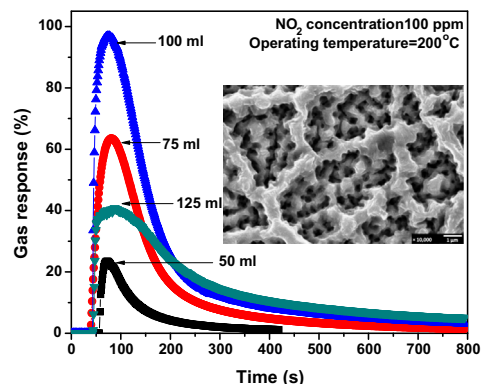


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## GRAPHICAL ABSTRACT



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## ABSTRACT

We report a study on effect of film thickness on NO<sub>2</sub> sensing properties of sprayed WO<sub>3</sub> thin films. WO<sub>3</sub> thin films varying in thicknesses are deposited onto the glass substrates by simple spray pyrolysis technique by varying the volume of spray solution. Thin film gas sensors are characterized by using X-ray diffraction (XRD), X-ray photoelectron spectroscopy (XPS), scanning electron microscopy (SEM), atomic force microscopy (AFM) and photoluminescence (PL) techniques to study their physical properties. Film having thickness 745 nm has shown highest gas response of 97% with 12 and 412 s response and recovery times, respectively towards 100 ppm NO<sub>2</sub> concentration. Gas response of 20% is observed towards 10 ppm NO<sub>2</sub> at 200 °C operating temperature. Sensitivity of the optimal sensor is 0.83%/ppm when operating at 200 °C with 10 ppm lower detection limit. The response of the sensor is reproducible and WO<sub>3</sub> films are highly selective towards NO<sub>2</sub> in presence of mist of various interfering gases viz. H<sub>2</sub>S, NH<sub>3</sub>, LPG, CO and SO<sub>2</sub>.

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## 1. Introduction

The perception of the surroundings based on mere senses is related closely to the progress of human/living being life. The smell

or more specifically, the gas detection is a quite complicated sensorial practice which has an effect on human's decisions and actions. Humans are unable to detect number of gases such as CO, CO<sub>2</sub>, CH<sub>4</sub>, H<sub>2</sub>, NO, NO<sub>2</sub> by smell above certain concentrations which can have fatal consequences if remained undetected and uncontrolled [1]. The massive usage of vehicles produce polluting gases such as CO, NO<sub>x</sub>, SO<sub>2</sub>, particles, and hydrocarbons [2] thus,

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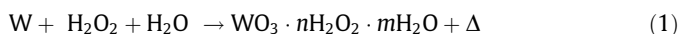
it is obligatory to develop sensitive gas sensors to detect even sub-ppm of specific analyte gas in a complex gas mixture [3]. According to various studies done so far and available reports by the various environment monitoring/protection agencies significant air pollutants are  $O_3$ ,  $NO_2$ ,  $SO_2$ ,  $CO$ , and particulate matter (lead) [2,4]. Among these pollutants risks to human lives due to  $NO_2$  is high. When inhaled,  $NO_2$  can be easily detected by its smell but at the same time, it is toxic.  $NO_2$  detection by its smell is easiest way provided its concentration is below 4 ppm; otherwise it anaesthetizes the nose [5]. Thus, many times when  $NO_2$  is leaked it remains unnoticed without use of some external sensing agency which may result in potential health risks. As far as  $NO_x$  sensing is concerned,  $WO_3$  is the most popularly used material. Currently some of the  $WO_3$  sensors are capable of measuring accurately in the 10 ppb range, which is well below the emergency exposure limit for human [6].  $WO_3$  nanowires were prepared by a vapour transport method using  $WO_3$  powder as a raw material. The sensor made of the nanowires as thin as 50 nm showed the highest response towards 3 ppm  $NO_2$  at a low operating temperature of 100 °C [7]. Irregular nanosheets of  $WO_3$  have been prepared and high response to  $NO_2$  even at sub-ppm level was observed by You et al. [8]. Using  $TeO_2$  templates An et al. [9] synthesized  $WO_3$  nanotubes and used for the detection of low  $NO_2$  concentrations ranging from 1 to 50 ppm. A report discussing the effect of thickness variation of the  $WO_3$  thin film on the  $NO$  response is available [10]. It is reported that thickness of the film affects the response and recovery kinetics of the sensor [11]. Dependence of the gas sensing performance on the thickness of thin films for various gases and materials is studied [12–17]. Desired thickness of the films is tuneable by controlling the preparative parameters. In spray pyrolysis method, by controlling the quantity of precursor solution to be sprayed, desired thickness of the thin films can be achieved.

We have made an attempt to develop a gas sensor based on  $WO_3$  thin films deposited by simple spray pyrolysis technique. Variation in the thickness of the films has effect on various properties such as morphology, porosity, defects, composition, etc. and hence on the gas sensing behaviour. The effect of thickness variation on the physicochemical and  $NO_2$  sensing properties of  $WO_3$  thin films deposited by varying the film thickness is discussed in the present work.

## 2. Experimental

### 2.1. Materials synthesis

The substrates were cleaned by the procedure discussed elsewhere [18]. The peroxotungstic acid (PTA) of 0.5 mM concentration was prepared by dissolving (2.757 g) tungsten metal powder (AR grade, 99%; loba chimie Pvt. Ltd., Mumbai) in 30 ml of 30% hydrogen peroxide ( $H_2O_2$ ) (AR grade; Thomas Bakers, Pvt. Ltd. Mumbai). The solution was initially kept in an ice bath for an hour to control the exothermic reaction. It is then rigorously stirred for 48 hours at room temperature until all the powder was completely dissolved according to reaction (1).



PTA thus formed was then diluted using double distilled water to 15 mM and used for the spray deposition. Thickness of the films was varied by varying solution quantity of the solution in four subsequent steps as 50, 75, 100, and 125 ml and the films were labelled as  $W_{345}$ ,  $W_{675}$ ,  $W_{745}$  and  $W_{801}$ , respectively according to their thickness (Table 1). PTA was sprayed on to the preheated glass substrates at optimized substrate temperature of 425 °C [19]. The nozzle to substrate distance was kept 28 cm and the spray rate was maintained at optimized value of 5 ml/cc.

### 2.2. Materials characterization

The deposited films were characterized by various techniques. To identify the crystal structure, the thin films were characterized by X-ray diffraction (XRD) technique and the diffraction patterns were recorded using Bruker D2 phaser X-ray diffractometer using  $Cu K_{\alpha}$  radiation of wavelength 1.5406 Å. Monochromatic X-ray beam of energy 1253.6 eV was used in X-ray photoelectron spectroscopy (XPS) study (XPS, Physical Electronics PHI 5400, USA); which reveals information about chemical composition and valence state of the elements. Surface morphology and topography of the films were studied using scanning electron microscopy (SEM, Model JEOL JSM-6701F, Japan) and atomic force microscopy (AFM, Digital Instrument, Nanoscope III). Absorption spectra obtained from UV–Visible spectrophotometer (UV–vis 1800 Spectrophotometer, Shimadzu) was used to determine optical band gap. Room temperature photoluminescence (PL) spectra were recorded using Perkin–Elmer luminescence spectrometer model: LS55 to study the defects. Thickness of the films was measured by means of surface profiler (XP-1 Stylus Profiler, Ambios Technology Inc.).

Gas sensing measurements were carried out in locally fabricated gas sensing unit equipped with Keithley electrometer (6514). Sensor of size 1 cm × 1 cm was fabricated and silver contacts were drawn for good electrical contacts. Thin film sensor was mounted in 250 ml airtight container where it is preheated at required temperature using temperature controller. Sensor was heated until its resistance stabilized and the time required for this was around three hours. Thin film sensors were then exposed to the analyte gas of desired concentration in the gas sensor unit and change in the resistance was monitored using Keithley (6514) electrometer. After each successive measurement, fresh air was passed into the test box and then required amount of analyte gas was injected into the box to obtain a desired concentration. Selectivity studies were carried out by monitoring change in resistance of the film by purging various gases of desired concentration. Various canisters of  $CO$ ,  $NH_3$ ,  $SO_2$ ,  $LPG$ ,  $H_2S$  and  $NO_2$  gases having 2000 ppm gas concentration were used as analyte gases procured from Shreya Enterprises Pvt. Ltd. Mumbai, Maharashtra, India.

## 3. Results and discussion

### 3.1. X-ray diffraction studies

XRD patterns of  $WO_3$  thin films with different thickness along with the stick pattern of JCPDS card are presented in Fig. 1. XRD

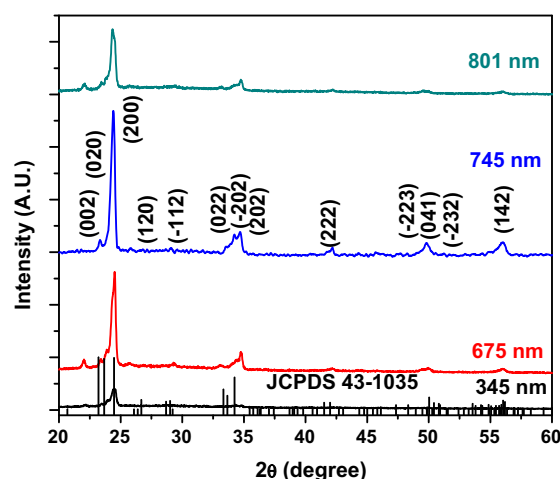


Fig. 1. X-ray diffraction patterns of  $WO_3$  thin with different thickness.

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